

A major concern in the development of a future quantum processor is the scalability toward large numbers of qubits; its structure should enable one- and multi-qubit gates on arbitrarily selected qubits. As for a classical processor, micro fabrication leads to a promising route to build such a versatile ion-qubit quantum processor. Recent experiments with surface electrode ion traps have demonstrated the key ingredients for scalable ion loading, transporting, and trapping architecture. Here, we present an approach to incorporate ion-qubit manipulation into the surface-electrode structure which could enable its duplication along with the other infrastructure.

In ongoing experiments we investigate the building block for a microwave near-field quantum control. It is based on an oscillating magnetic field generated by microwave currents in electrodes of a micro fabricated surface-electrode trap. The driving microwave frequency is tuned near resonant with a hyperfine transition in the Mg ion. The homogeneous field component is used to implement single-qubit gates, while the field gradient leads to a coupling of the ions internal and motional states. With further improvements, this coupling can be deployed to perform a multi-qubit operation.



-1043.61 MHz

National Institute of Standards and Technology; 325 Broadway, Boulder, Colorado 80305, USA Supported by IARPA, NSA, DARPA, ONR and the NIST Quantum Information Program

